

Contribution ID: 50 Type: Poster

Extending the Aspect Ratio of Etched Silicon for Precision Electro-coating with Gold to Fabricate XPCI Analyzer Gratings

Wednesday 13 September 2017 12:30 (2 hours)

Author: FINNEGAN, Patrick (Sandia National Laboratories)

Co-authors: Dr DAGEL, Amber (Sandia National Laboratories); HOLLOWELL, Andrew (Sandia National Laboratories); Dr PEREZ, Carlos (Sandia National Laboratories); ARRINGTON, Christian (Sandia National Laboratories); Dr COLEMAN, Jonathan (Sandia National Laboratories)

Presenter: FINNEGAN, Patrick (Sandia National Laboratories)

Session Classification: Lunch break & Poster session

Track Classification: Fabrication Methods